

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/720,541	KIM ET AL.	
Examiner	Art Unit	
Jason Heckert	1746	

SEARCHED				
Class	Subclass	Date	Examiner	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH (INCLUDING SEA	I NOTES RCH STRATEG	()
	DATE	EXMR
Updated Search	5/18/2007	ЈМН
Consulted J. Perrin	5/17/2007	ЈМН
Consulted M. Barr	5/17/2007	ЈМН